



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Takashi KATO, et al.)	Examiner: Unassigned
Appln. No.: 09/820,710)	Group Art Unit: 2872
Filed: March 30, 2001)	
For: PROJECTION OPTICAL SYSTEM AND PROJECTION EXPOSURE APPARATUS)	October 10, 2001

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R. Jones
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Commissioner for Patents
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on July 9, 2001, and to comply with the duty of disclosure under 37 CFR 1.56 and in accordance with the practice under 37 CFR 1.97 and 1.98, the Examiner's attention is directed to the corresponding U.S. patent application listed below and on the enclosed PTO-1449 Form. A copy of the listed application is also enclosed.

U.S. Patent Application No. 09/337,258

Filing Date: June 22, 1999

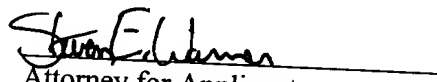
U.S. patent application no. 09/337,258, filed June 22, 1999, entitled "Projection Exposure Apparatus and Device Manufacturing Method," corresponds to Japanese patent document JP 2000-12440, submitted in the Information Disclosure Statement filed July 9, 2001. That document shows an optical arrangement in which a pair of optical elements having diffraction grating surfaces of the same shape are disposed with their diffraction grating surfaces opposed to each other, and these optical elements are applied to a catadioptric system.

Applicants request that the Examiner consider the cited information and return an initialed copy of the enclosed PTO-1449 Form indicating that such information has been considered.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Assistant Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,


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